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Bib Data Sheet

CONFIRMATION NO. 7432

SERIAL NUMBER 10/010,850	FILING DATE 12/05/2001 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. SD6957S97604
APPLICANTS Peggy J. Clews, Tijeras, NM; Seethambal S. Mani, Albuquerque, NM;				
** CONTINUING DATA ***** <i>none</i>				
** FOREIGN APPLICATIONS ***** <i>none</i>				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/29/2002				
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met <i>allowance</i> Verified and <i>binh tran</i> Acknowledged <i>binh tran</i> Examiner's Signature Initials		STATE OR COUNTRY NM	SHEETS DRAWING 1	TOTAL CLAIMS 18
				INDEPENDENT CLAIMS 2
ADDRESS Sandia National Laboratories P. O. Box 5800 - MS-0161 Albuquerque, NM 87185-0161				
TITLE Selective etchant for oxide sacrificial material in semiconductor device fabrication				
FILING FEE RECEIVED 740	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees	
			<input type="checkbox"/> 1.16 Fees (Filing)	
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			<input type="checkbox"/> 1.18 Fees (Issue)	
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